

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Priority Application Serial No. ..... 09/653,156  
Priority Filing Date ..... August 31, 2000  
Inventor..... Vishnu K. Agarwal, et al  
Assignee..... Micron Technology, Inc.  
Priority Group Art Unit ..... 2813  
Priority Examiner ..... Y. Huynh  
Attorney's Docket No. ..... MI22-1913  
Title: Capacitor Fabrication Methods and Capacitor Constructions

**INFORMATION DISCLOSURE STATEMENT**

**PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98**

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a application of co-pending application Serial No. 09/653,156, filed August 31, 2000. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned. 37 C.F.R. § 1.98(d) and MPEP § 609(2).

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 15 Jan 2002

By: Jane E. Lake

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